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SUGHRUE MION, PLLC

January 24, 2002

BOX PATENT APPLICATION
Commissioner for Patents
Washington, D.C. 20231

Re: Application of Masayuki NAYA, Takashi Kubo, Takashi Ito and
Yoshimitsu Nomura
SURFACE PLASMON RESONANCE MEASURING CHIP AND METHOD OF
MANUFACTURE THEREOF
Assignee: FUJI PHOTO FILM CO., LTD.
Our Ref. Q66584

Dear Sir:

Attached hereto is the application identified above comprising forty-six (46) sheets of the specification, including the claims and abstract and, fifteen (15) sheets of drawings, Information Disclosure Statement and PTO 1449 form with references. **The requisite U.S. Government Filing Fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.**

The Government filing fee is calculated as follows:

Total claims	<u>13</u> - 20	=	<u> </u>	x	\$18.00	=	<u> </u>	\$0.00
Independent claims	<u>2</u> - 3	=	<u> </u>	x	\$84.00	=	<u> </u>	\$0.00
Base Fee								\$740.00
TOTAL FEE								<u>\$740.00</u>

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	016632/2001	January 25, 2001

The priority document is submitted herewith.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By: Darryl Mexic
Darryl Mexic
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DM/ob